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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Kouji TOMETSUKA et al. :
Serial No: Unassigned (Filed Herewith) :
Filed: July 25, 2001 (Filed Herewith) :
For: Substrate Processing Apparatus And Method

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09/911741
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Assistant Commissioner of Patents
and Trademarks
Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

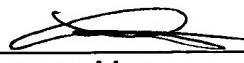
Pursuant to Rule 37 C.F.R. §1.56, §1.97 and §1.98, this Information Disclosure Statement is submitted in the above-identified patent application. A listing of documents to be published on the face of any patent granted from this application is submitted herewith on Form PTO-1449. Any other documents or information submitted for consideration by the Examiner are listed in this paper.

This Information Disclosure Statement is submitted before the mailing of the first Office Action on the merits.

The Examiner is requested to acknowledge consideration of the information provided in this paper in accordance with prescribed procedures.

Please charge any additional fees or credit any overpayments in connection with this paper to Deposit Account No. 02-0200.

Respectfully submitted,


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